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APPLICATION NO.	FILING DATE		FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
09/498,303	02/04/2000		Yong-Pil Han	MIT7941	8629	
75	90	03/13/2002				
Theresa A Lob			EXAM	EXAMINER		
T A Lober Pater 45 Walden Stree	et	ces	DANG, THI D			
Concord, MA	01742			ART UNIT	PAPER NUMBER	
				1763	4	

Please find below and/or attached an Office communication concerning this application or proceeding.

		Applicati n No).	Applicant(s)				
	•	09/498,303		HAN ET AL.				
•	Office Action Summary	Examiner		Art Unit				
•		Thi Dang		1763				
Period fo	- The MAILING DATE of this communication ap	pears on the cov	r sheet with the c	orrespondence addr	ess			
	T REPLY ORTENED STATUTORY PERIOD FOR REPL	VIS SET TO EX	PIRE 3 MONTH	S) FROM				
THE N - Exten after: - If the - If NO - Failur - Any re earne	MAILING DATE OF THIS COMMUNICATION. sions of time may be available under the provisions of 37 CFR 1. SIX (6) MONTHS from the mailing date of this communication. period for reply specified above is less than thirty (30) days, a reperiod for reply is specified above, the maximum statutory period to treply within the set or extended period for reply will, by statutely received by the Office later than three months after the mailing patent term adjustment. See 37 CFR 1.704(b).	136(a). In no event, how by within the statutory many will expired the second will expired the application	wever, may a reply be tim inimum of thirty (30) days e SIX (6) MONTHS from to become ABANDONEI	nely filed s will be considered timely. the mailing date of this com D (35 U.S.C. § 133).	nunication.			
Status								
1) 🗌	Responsive to communication(s) filed on							
2a)☐	,	his action is non-						
3)	Since this application is in condition for allow closed in accordance with the practice under				merits is			
Dispositi	on of Claims							
4) 🖾	Claim(s) 1-24 is/are pending in the application	n.						
•	4a) Of the above claim(s) is/are withdrawn from consideration.							
5)⊠	Claim(s) <u>12-14 and 16-21</u> is/are allowed.							
6)⊠	☑ Claim(s) <u>1-11 and 22-24</u> is/are rejected.							
7) 🖾	☑ Claim(s) <u>15</u> is/are objected to.							
•	Claim(s) are subject to restriction and/on Papers	or election requir	ement.					
	Fhe specification is objected to by the Examin	er						
, —	The drawing(s) filed on is/are: a)□ acce		cted to by the Exa	miner.				
. 5/								
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a). 11) The proposed drawing correction filed on is: a) approved b) disapproved by the Examiner.								
If approved, corrected drawings are required in reply to this Office action.								
12) The oath or declaration is objected to by the Examiner.								
Priority under 35 U.S.C. §§ 119 and 120								
13)	Acknowledgment is made of a claim for foreig	n priority under	35 U.S.C. § 119(a)-(d) or (f).				
a) ☐ All b) ☐ Some * c) ☐ None of:								
	1. Certified copies of the priority documents have been received.							
	2. Certified copies of the priority documents have been received in Application No							
* S	3. Copies of the certified copies of the pri- application from the International B see the attached detailed Office action for a lis	ureau (PCT Rule	: 17.2(a)).		age			
14)∐ A	cknowledgment is made of a claim for domes	tic priority under	35 U.S.C. § 119(e	e) (to a provisional a	pplication).			
a	The translation of the foreign language pracknowledgment is made of a claim for domes	rovisional applica	tion has been rec	eived.				
Attachment	•	·						
2) Notic	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948) nation Disclosure Statement(s) (PTO-1449) Paper No(s)		Notice of Informal I	v (PTO-413) Paper No(s) Patent Application (PTO-				

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Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

Claims 1-6 are rejected under 35 U.S.C. 103(a) as being unpatentable over *Tanaka* et al (5,288,333).

Tanaka discloses a wafer cleaning method in which a mixture of HF and H₂0 vapors is applied to the surface of a semiconductor device at a temperature above its dew point (cols. 11-12). The pressure and temperature conditions are controlled during cleaning to prevent aerosol formation, thus, allowing uniform etching. It is obvious that no more than a sub-monolayer of etch reactants is formed on the semiconductor device in Tanaka's method because Tanaka's method involves etching with HF and H₂0 vapors as in the case of applicants' method and the pressure and temperature are controlled so as to prevent aerosol formation. It is expected that any reaction products formed on the surface of the semiconductor device during Tanaka's

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method would be vaporized. The claims broadly recite that the pressure and temperature conditions are controlled to produce a monolayer or sub-monolayer of etch reactants, but no specific pressure or temperature is stated. In addition, the term "submonolayer" is broad in its scope, and thus, does not further limit the claims in the way that would define the claimed method over that of *Tanaka*. As broadly claimed, applicants' method does not define over that of *Tanaka*.

Claims 7-11 and 22-24 are rejected under 35 U.S.C. 103(a) as being unpatentable over *Rose* et al.

Rose discloses a method for removing an oxide layer from a semiconductor device in which the oxide layer is exposed to an aerosol of frozen particles and a mixture of HF and water vapor (col. 5, lines 1-24). It is obvious that no more than a sub-monolayer of etch reactants is formed on the semiconductor device in Rose's method because Rose's method involves exposing the oxide layer to frozen particles and etching with HF and water vapors as in the case of applicants' method.

Claim Objections

Claims 9, 10,15, 23, 24 are objected to because of the following informalities: The term "to from" in each of the above claims contains a spelling error; it should be changed to -- to form--. Appropriate correction is required.

Allowable Subject Matter

Claims 12-14 and 16-21 are allowed.

The application having been allowed, formal drawings are required in response to this Office Action.

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Conclusion

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Jeng et al. and Watanabe et al are cited to show prior art methods of removing oxides that are related to the claimed invention.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Ms. Thi Dang whose telephone number is (703) 308-1973. The examiner can normally be reached on Monday to Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gregory Mills can be reached on (703) 308-1633. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 872-9310 for regular communications and (703) 872-9311 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0661.

TD

March 12, 2002

THI DANG PAINER